



THE UNITED STATES PATENT & TRADEMARK OFFICE

In re application of: Lea DI CIOCCIO

Serial No: 09/582,630

Group: 2825

Filed: July 26, 2000

Examiner: CARIDAD EVERHART

For: PROCESS FOR FABRICATING A STRUCTURE OF SEMICONDUCTOR-ON-INSULATOR TYPE, IN PARTICULAR SICOI

REQUEST FOR PRIORITY ACKNOWLEDGEMENT UNDER 35 U.S.C. 119
AND THE INTERNATIONAL CONVENTION

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In the matter of the above-identified application for patent, notice is hereby given that the Applicant(s) claim as priority:

Country
FRANCE

Application No.
98/00899

Month/Day/Year
JANUARY 28, 1998

Certified copies of the corresponding Convention Application(s) were submitted to the International Bureau in PCT Application Number PCT/FR99/0155 filed on JANUARY 27, 1998. Receipt of the certified copies by the International Bureau in a timely manner under PCT Rule 17.1(a) has been acknowledged as evidenced by the attached PCT/IB/304.

Respectfully submitted,

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